9-16-05

P E Appl. No. 09/212,726

m 2813

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

•/	
Application Serial No	09/212,726
Filing Date	December 15, 1998
Inventor	
Assignee	
Group Art Unit	
Examiner	
Attorney's Docket No	MI22-1098
Title: Semiconductor Processing Methods of Chemic Substrate	cal Vapor Depositing SiO ₂ on a

RESPONSE TO JUNE 14, 2005 OFFICE ACTION

To:

Mail Stop Amendment Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

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AMENDMENTS

Introductory Comments

In reply to the office action dated June 14, 2005, applicant amends and remarks as follows.